



IPW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

Soojin Oh et al.

Application No.: 10/615,842

Filed: July 10, 2003

For: DEPOSITION METHOD FOR  
NANOSTRUCTURE MATERIALS

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)  
) Group Art Unit: 1753

)  
) Examiner: Brian L. Mutschler

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) Confirmation No.: 9995

**SECOND STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A response to our Status Inquiry filed on January 18, 2005 was never received.  
Please advise in writing of the current status of the above-captioned application.

Respectfully submitted,

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Date: August 18, 2005

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